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U.S. DEPA	RTMEN	NT OF COMMERCE, PA	ATEN	T AND TRAD	EMAF	RK OFFICE	D	OCKET NO	o.	SERIAL N	0.
(PTO FORM 1449 MODIFIED)						AMAT/5699			10/038,066		
LIST OF	PATE	NTS AND PUBLICA	1OIT	VS CITED	BY A	PPLICANT		PPLICANT hen, et a		CONFIRM No. UNKNOWN	
(USE SEVE	RAL SH	HEETS IF NECESSARY))				F	ILING DAT	E	GROUP J	747_
		EXAMINER UNK	1WO	N			Já	anuary 3,	2001	TINKNOW	
U.S. Pate	nt Doc	cuments									
*EXAMINE R INITIAL		DOCUMENT NUMBER		ISSUE DATE		APPLICANT(S) NAME		CLASS	SUBCLAS S	FILING DATE APPROPRIA	
AW	A1	2001/0024878		SEPT 27, 2001		NAKAMURA		438	691	MARCH 26	, 2001
HU	A2	2001/0042690		Nov 22,2001		TALIEH		205	118	DEC 14, 20	000
MW	A3	6,248,222		JUNE 19, 2001		WANG		204	297.09	SEPT 7, 19	999
AW.	A4	6,234,870		May 22, 2001		UZOH, ET AL		451	8	AUG 24, 1	999
. KW	A5	6,176,992		JAN 23, 2001		TALIEH		205	87	DEC 01, 19	998
AN	A6	6,103,096		Aug 15, 2000		DATTA		205	686	Nov 12, 1	997
HW	A7	6,066,030		May 23, 2000		Uzoh		451	41	MARCH 4,	1999
HW	A8	5,911,619		JUNE 15, 1999		UZOH, ET AL		451	5	MARCH 26	, 1997
AW	A9	5,807,165		SEPT 15, 1998		UZOH, ET AL		451	41	March 26	, 1997
#W	A10	5,846,882		DEC 8, 199	98	BIRANG		438	692	Ост 3, 19	96
Foreign P	atent	Documents									
			DA	ATE COUNTRY		NTRY	CLASS		SUBCLASS	Translation	
INITIAL		Number								YES	NO
AW	B1	P2001-77117A	03	/23/2001	JP		Н	01L	21/3205		
HW	B2	98/49723	11	/05/1998	WO	W.	Н	01L	21/321		
OTHER A	RT										
*EXAMINER INITIAL		INCLUDING AUTHOR PERTINENT PAGES			*						
WH	C1		NOGAMI," AN INNOVATION TO INTEGRATE POROUS LOW-K MATERIALS AND COPPER", INTERCONNECT JAPAN 2001; HONEYWELL SEMINAR (DECEMBER 6, 2001) PP. 1 – 12								
EXAMINER	IA.	us 50 /s		511	·		D	ATE CON	SIDERED (1/19/0	3
	R: INITI	AL FREFERENCE CONSI									

U.S. DEPARTMENT OF COMMERCE, PATENT AND TRADEMARK OFFICE						DOCKET	No.	SERIAL NO.	
(PTO FORM 1449 MODIFIED)						AMAT/5	699	10/038,066	
LIST OF P	ATENT	TS AND PUBL	ICA	TIONS CITED	BY APPLICANT	APPLICA Chen, e		CONFIRM NO. UNKNOW	
(USE SEVER	RAL SHE	ETS IF NECESSA	RY)			FILING D	ATE	GROUP	1742
EXAMINER UNKNOWN							January 3, 2002		
U.S. Paten	t Docu	ments					-		
*EXAMINER INITIAL		DOCUMENT NUMBER	_	SUE ATE	APPLICANT(S) NAME	CLASS	SUBCLAS S	FILING DATE APPROPRIATE	
HW	A11	5,575,706	N	ov 19, 1996	TSAI, ET AL	451	41	JAN 11, 19	96
MW	A12	5,567,300	0	ст 22, 1996	DATTA, ET AL	205	652	SEPT 2, 19	94
1W	A13	5,543,032	Α	UG 6, 1996	DATTA, ET AL	205	670	JUNE 2, 19	95
HW	A14	5,534,106	Jı	ULY 9, 1996	COTE, ET AL	156	636.1	JULY 26, 1	995
HW	A15	5,225,034	Jı	ULY 6, 1993	YU, ET AL	156	636	JUNE 4, 1	992
WW.	A16	5,217,586	Jı	UNE 8, 1993	DATTA, ET AL	204	129.6	JAN 9, 1992	
AW	A17	4,934,102	JUNE 19, 1990		LEACH, ET AL	51	50 R	Ост 4, 1988	
· baw	A18	4,793,895	D	EC 27, 1988	KAANTA, ET AL	156	627	JAN 25, 19	88
Foreign Pa	itent De	ocuments							
*EXAMINER		DOCUMENT NUMBER		DATE	COUNTRY	CLASS	SUBCLAS	TRANSLATION	
İNITIAL							S	YES	NO
OTHER AF	RT					.,		•	
*EXAMINER INITIAL		INCLUDING AUTPERTINENT PA		R, TITLE, DATE, , ETC.	•				<u> </u>
EXAMINER	Har	WS	<u>න</u>	MM i -	111	DATE CO	ONSIDERED	1/19/	OJ
					R OR NOT CITATION IS I				

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U.S. Depai	rtment c	of Commerce Pate	ent and radem	nark Office	Docket 1	lo.	Serial No	•
(PTO Form	1449 r	nodified) APR	2 2 2003		AMAT/56 MP/RKK	699/CMP/C	10/038,06	66
SUPPLEM APPLICAN		INFORMATION	DISCLOSURE IS TRADE	STATEMENT BY	Applican Chen, et		Confirma 5741	tion No.
(Use sever	al shee	ts if necessary)			Filing Da	te	Group	
		Examiner Unk	nown		January	3, 2002	2812- /	142
U.S. Pater	t Docu	ments			1		<u>-</u>	
*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date I Appropriate	f
	A1							
	A2					, ¹	ECEIVE	- M
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	A4					APR	2 9 7003	
	A5					GRO	UP 1700)
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	A12					80		
Foreign Pa	atent D	ocuments						
*Examiner Initial		Document Number	Date	Country	Class	Subclass	Transla YES	tion NO
WW	B1	00/26443	05-11-2000	wo	C25D			\boxtimes
1/W	B2	1 618 538 A1	01-07-1991	SU	B23	H5/6		\boxtimes
ÑW,	В3	0 846 842 A2	06-10-1998	EP	C09G	1/02		
W	B4	99/65072	12-16-1999	WO	H01L	21/321		\boxtimes
	B5							
OTHER AF	RT							
*Examiner Initial		Including Author, Pertinent Pages,						
	C1	International Se	arch Report for	PCT/US02/04806	dated Apri	11, 2003		
	C2							
	C3				_			
Examiner	Hem	x D. Ni	MA		Date Cor	nsidered /	1/19/0	3
				not citation is in confo le copy of this form w				ough

				*K			Sheet 1 of	1 sheets
U.S. Depart	ment of	Commerce, Pare	nt and Tradem	ark Office	Docket No	5.	Serial No	
(PTO Form		/	onna		AMAT/569 MP/RKK	99/CMP/C	10/038,06	66
SUPPLEME APPLIÇAN		INFORMATION D	ISCLOSURE S	STATEMENT BY	Applicant Chen, et a	al.	Confirmation 5741	tion No.
(Use severa	al sheet	s if necessary) 1DE	AAPPE		Filing Dat	 e	Group	
		Examiner Unkn			January 3	, 2002	2812_ [742
U.S. Patent	Docur	nents						
*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date I Appropriate	f
MW	A1	6,143,155	11/07/2000	Adams, et al.	205	87	06/11/1998	
MM	A2	6,077,412	06/20/2000	Ting, et al.	205	143	10/30/1998	
AW	A3	6,056,864	05/02/2000	Cheung	205	222	10/13/1998	
AW	A4	6,004,880	12/21/1999	Liu, et al.	438	692	02/20/1998	3
the	A5	5,256,565	10/26/1993	Bernhardt, et al.	437	228	05/08/1989	
WA	A6	5,129,981	07/14/1992	Wang, et al.	156	628	03/14/1991	
MW	A7	5,096,550	03/17/1992	Mayer, et al.	204	129.1	10/15/1990)
WW	A8	4,663,005	05/05/1987	Edson	204	129.85	09/03/1986	
AW	A9	2,582,020	01/08/1952	Emery	204	140.5	07/15/1947	,
	A10						·	
	A11							
	A12							
Foreign Pa	tent Do	cuments				-	_	
*Examiner		Document	Date	Country	Class	Subclass	Transla	tion
Initial		Number					YES	NO
	B1				110/00			· 🗆
	B2				"RECE	IVED		
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	B4			GF	POUP 1	700		
	B5					, 00	5 23	
OTHER AR	T							5
*Examiner Initial		Including Author, 1 Pertinent Pages, E				;	ROOM	•
My	C1	D. Landolt, "Fund	damental Aspe	cts of Electropolish	ning", 03/18	/1996 page	s: 1-11	
	C2							
	C3							
Examiner	fler	y LI ONI	L III		Date Con	sidered	11/19/03	
				ot citation is in confo e copy of this form w				ough

U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified) INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary) MAY 2 2 2003 Filing Date Docket No. AMAT/5699/CMP/C MP/RKK Applicant CHEN, et al. Filing Date Group	on No.:
INFORMATION DISCLOSURE STATEMENT BY APPLICANT Applicant CHEN, et al. (Use several sheets if necessary) MAY 2 2 2003 Filing Date Group	on No.:
(Use several sheets if necessary) MAY 2 2 2003 Filing Date Group	
(Use several sheets if necessary) MAY 2 2 2003 Filing Date Group	42
	42
	42
Examiner Unknown January 3, 2002 2812 17	
U.S. Patent Documents	
*Examiner Document Issue Applicant(s) Class Subclass Filing Date Initial Number Date Name Appropriate	
A1 6,276,996 B1 08/21/2001 Chopra 451 41 11/10/1998	3
10 h	3
A3 4,263,113 A 04/21/1981 Bernard 204 146 07/02/1980)
A4 2002/108861 A1 08/15/2002 Emesh, et al. C25D 11/02 02/12/200	1
A5 2001/0036746 A1 11/01/2001 Sato, et al. 438 745 03/08/200	ı
A7	PE
A8 Go 3	, C
A6 A7 A8 A9 A10 A11	0700
A10	7>
A11	00
A12	
A13	
Foreign Patent Documents	
*Examiner Document Date Country Class Subclass Transla	tion
YES	NO
B1 02 075804 A2 09/26/2002 WO H01L 21/321	
B2 00 55876 A1 09/21/2000 WO H01G 9/035	
₩ B3 1 170 761 A1 09/01/2002 EP H01G 9/035 ⊠	
OTHER ART	
*Examiner Including Author, Title, Date, Pertinent Pages, Etc. Initial	
Robert J. Contolini, "Electrochemical Planarization of ULSI Copper" June 1997, Solid Technology, pages 155-156, 158, 160.	State
G2 International Search Report for PCT/US02/40754 dated April 28, 2003	
C3 1 1 + + + + + + + + + + + + + + + + +	
Examiner Army Date Considered 1/19/03	
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line throu citation if not in conformance and not considered. Include copy of this form with your communication to applicant.	ugh